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U. S. Patent Application Claiming Priority Of:

Int'l Application No.:	PCT/JP2005/001174
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Priority Date:	22 January 2004 (22.01.04)
Applicant:	TAKAGI, et al.
For:	VACUUM DEPOSITION METHOD AND SEALED-TYPE EVAPORATION SOURCE APPARATUS FOR VACUUM DE POSITION
Our File No.:	520514.00039

PRELIMINARY AMENDMENT

MAIL STOP PCT
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please enter into the record of the application filed herewith, the following amendments:

1. **Amendments to the Specification** begin on page 2 of this paper.
2. **Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.
3. **Remarks** begin on page 7 of this paper.